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INFORMATION  
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BY APPLICANTS

Dutta et al.  
Applicant

January 3, 2002  
Filing Date

Group Art Unit

Examiner's name

U.S. PATENT DOCUMENTS

Examiner's Initial	Document Number	Date	Name	Class/Sub-class
	NONE			

FOREIGN PATENT DOCUMENTS

Examiner's Initial	Document Number	Date	Country/Name	Translation ? yes/no
	NONE			


OTHER DOCUMENTS

1. Zhuyikov, S. et al., Stabilized Zirconia-Based NOx Sensor Using ZnFe2O4 Sensing Electrode, Electrochemical and Solid-State Letters, 4 (9), H19-H21 (2001). ✓
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4. Zhuiykov, S. et al., *Potentiometric NO<sub>x</sub> Sensor Based on Stabilized Zirconia and NiCr<sub>2</sub>O<sub>4</sub> Sensing Electrode Operating High Temperatures*, *Electrochemistry Communications* 3, 97-101 (2001).
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14. Kaneyasu, K. et al., *A Carbon Dioxide Gas Sensor Based on Solid Electrolyte for Air Quality Control*, *Sensors and Actuators B* 66, 56-58 (2000).
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All references were previously considered

Examiner 	Date Considered 8/31/01
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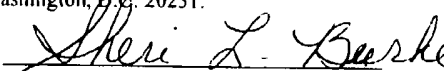
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Sheri L. Burke